

Electronic Patent Application Fee Transmittal

Application Number:	10615794			
Filing Date:	10-Jul-2003			
Title of Invention:	Void-free damascene copper deposition process and means of monitoring thereof			
First Named Inventor/Applicant Name:	Panayotis Andricacos			
Filer:	Donald K. Drummond/Selena Hamilton			
Attorney Docket Number:	20140-00302-US /YOR920030			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Filing a brief in support of an appeal	1402	1	510	510
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Total in USD (\$)				510